Form PTO-1449		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket No. 5649-927DV		Serial No. 10/706, 647			
LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)					Applicants: Hyoung-Joon Kim, Young-Wook Park, Byeong-Yun Nam				
·	(Us	e several sheets if r			Filing Date: To Be Assigned	1 11/12/2	003	GAU: 2822	
			U	.S. PATI	ENT DOCUME	NTS			
Examiner Initials		Document No.	Date	Name	·	Class	Subclass	Filing Date if Appropriate	
	1	1 .			ATENT DOCUM				
		Document Number	Date	Count	try	Class	Subclass	Translation Yes / No	
TMT	1.	9-97880	04/08/97	Japan				X (Abstract)	
	<u> </u>	OTHER D	DCUMENTS ((Includin	g Author, Title,	Date, Pertinent Pa	ges, Etc.)		
$\geq <$	2. Klaus et al., Atomic Layer Deposition of SiO ₂ Using Catalyzed and Uncatalyzed Self-Limiting Surface Reactions, Surface Review and Letters, Vol. 6, Nos. 3 & 4, 1999, pp. 435-448								
	-					`			
	-								
· · · · · · · · · · · · · · · · · · ·									

	T 10 7	•	
Examiner:	T.M. Thomas	Date Considered:	08-22-04

Examiner:

Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.